

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10694986
<b>Filing Date:</b>	29-Oct-2003
<b>Title of Invention:</b>	Method for removing resist pattern and method for manufacturing semiconductor device
<b>First Named Inventor/Applicant Name:</b>	Masaharu Nagai
<b>Filer:</b>	Roberto J. Devoto/kim bailey
<b>Attorney Docket Number:</b>	12732-171001

Filed as Large Entity

### Utility under 35 USC 111(a) Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
Claims in excess of 20	1202	16	52	832
Independent claims in excess of 3	1201	2	220	440

### Miscellaneous-Filing:

### Petition:

### Patent-Appeals-and-Interference:

### Post-Allowance-and-Post-Issuance:

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Total in USD (\$)				1272